

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Hidekazu MORIYAMA

Application No.: 10/827,426

Docket No.: 119295

Filed: April 20, 2004

For: CLEANING METHOD, STORAGE METHOD, PATTERN FORMATION METHOD,  
DEVICE MANUFACTURING METHOD, ELECTRO-OPTICAL DEVICE, AND  
ELECTRONIC APPARATUS

**REQUEST FOR CORRECTION OF PALM RECORDS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

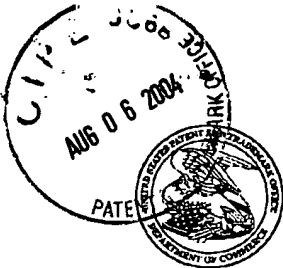
Michael Britton  
Registration No. 47,260

JAO:MB/cmf

Date: August 6, 2004

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
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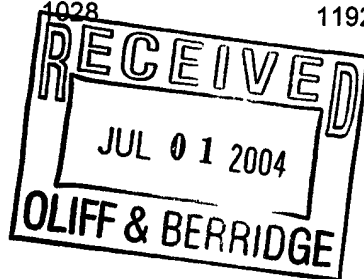


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/827,426	04/20/2004	1746	1028	119295	11	14	6

25944  
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CONFIRMATION NO. 2552

## FILING RECEIPT



\*OC000000013102596\*

Date Mailed: 06/29/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

NAGANO-KEN

Hidekazu Moriyama, Suwa-shi, JAPAN;

## Assignment For Published Patent Application

SEIKO EPSON CORPORATION, Tokyo, JAPAN;

## Domestic Priority data as claimed by applicant

## Foreign Applications

JAPAN 2003-117164 04/22/2003

If Required, Foreign Filing License Granted: 06/29/2004

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

## Title

Cleaning method, storage method, pattern formation method, device manufacturing method,  
 electro-optical device, and electronic apparatus

**Preliminary Class**

134

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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